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April 1, 2004

Oliff& Berridge, plc

ATTORNEYS AT LAW

## U.S. PATENT AND TRADEMARK OFFICE FACSIMILE TRANSMISSION COVER SHEET

To:	In re the Application of Akiro SATO			FOR FILING IN THE U.S. PATENT AND TRADEMARK OFFICE	
	Application No.: 09/424,500		9/424,500	Group Art Unit: 2825  Docket No.: 104788	
	Filed: February 22, 2000		2000		
	For:	: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE, MOLDING DEVICE FOR SEMICONDUCTOR DEVICE, AND SEMICONDUCTOR DEVICE			
Examiner:		G. Lee		Facsimile: (703) 872-9306	
From		es A. Oliff . No. 27,075			
Prepared By: mlv Number			Numbe	r of Pages Sent (Including cover sheet): 3	
Comments:					
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## PT ECEIPT FOR FILING OF PAPERS

➤ Mail Room (Regular Delivery)

The following papers have been filed:

RCE; AND CHECK NO. 144081 (\$750.00).

Name of Applicant: Akiro SATO 09/424,500\_ Serial No.:\_\_ 104788 Atty. File No.:

Title (New Cases):

Sender's Initials: JAO:LMS



PATENT OFFICE DATE STAMP

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## **PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RECEIVED
CENTRAL FAX CENTER

In re the Application of

Akiro SATO

عثره أداء فدانها

Group Art Unit: 2825

APR - 1 2004

Application No.: 09/424,500

Examiner:

G. Lee

Filed: February 22, 2000

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MAIL STOP RCE

OFFICIAL

For: METHOD OF M

METHOD OF MANUFACTURING

SEMICONDUCTOR DEVICE, MOLDING DEVICE FOR SEMICONDUCTOR DEVICE,

AND SEMICONDUCTOR DEVICE

LARGE ENTITY REQUEST FOR CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicant hereby requests continued examination and entry and consideration of the Amendment After Final Rejection submitted on April 21, 2003. The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 144081 in the amount of  $\boxtimes$  \$750.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

Respectfully submitted.

James A. Oliff

Registration No. 27,075

Linda M. Saltiel

Registration No. 51,122

JAO:LMS/rxg

Date: July 11, 2003

OLIFF & BERRIDGE, PLC

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